Research Division of Electron Microscopy Theory Research Center for Ultra-High Voltage Electron Microscopy

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We work on developing and researching methods for measuring microstructures using the advanced electron microscopes including the 3 million volt ultra-high

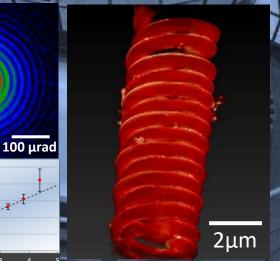
voltage electron microscope.

 $L_{sc} = \eta \ D_{beam} + \xi$ $\eta = 0.073 \pm 0.005$ $\xi = 26 \pm 7$

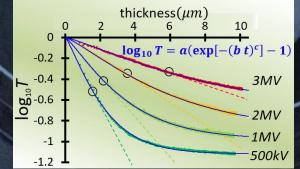
> 2 3 ビーム径 (μm)

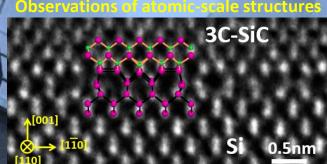
3 million vol ultra-high voltage electron microscope 15m

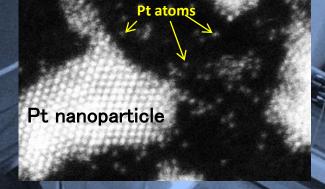
Measurements of 3D observations of wave nature of micron-scale materials electrons



Analysis of scattering phenomenon of high-energy electrons by materials







Measurements of nanometerscale electric fields

